Atty. reference: OKI 412

SPECIFICATION AMENDMENTS:

Please replace the paragraph from page 1, line 16 through page 2, line 2, with the following amended paragraph:

In recent years, semiconductor integrated circuit devices such as LSI have been requested asked to have an enlarged scale or multiple functions, and there has been a tendency to complication of a complicate the constitution of the semiconductor integrated circuit device and to [[an]] increase [[of a]] the circuit area. This has involved resulted in an increase in [[a]] resistance by drawing around a power wiring and a ground wiring disposed in the semiconductor integrated circuit device, or in a decrease in a power voltage for the purpose of saving [[a]] power consumption and increasing [[a]] the speed of the circuit. This has caused a voltage drop [[of a]] in the supply voltage in the circuit circuits disposed in a position positions distant from a power supply, and has caused problems such as [[a]] defective operation and [[an]] a decrease in the operation speed decrease of the circuit.